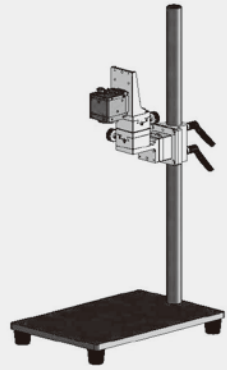
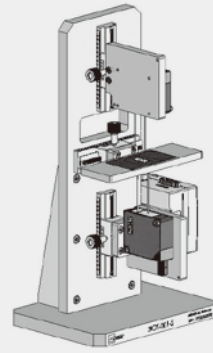


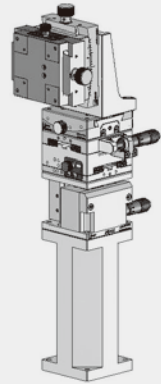
Simplified & rapid adjustment module for CCD monitoring.



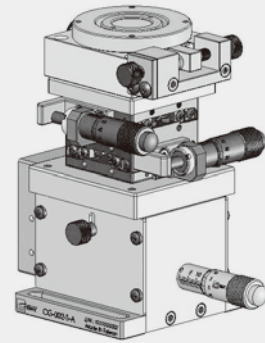
Measuring module for membrane thickness of transparent material.



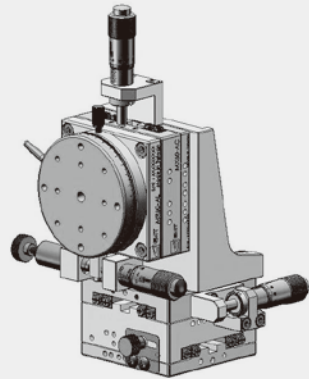
Multiple axes module for Universal fine tuning.



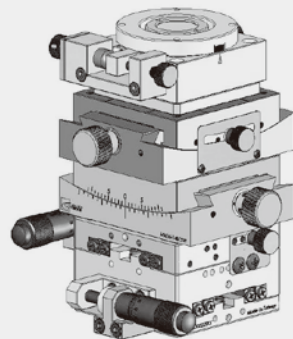
Multi-axes, micro-adjustment module.



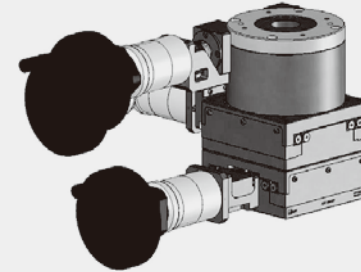
Micro-alignment module of CCD fabricated equipment.



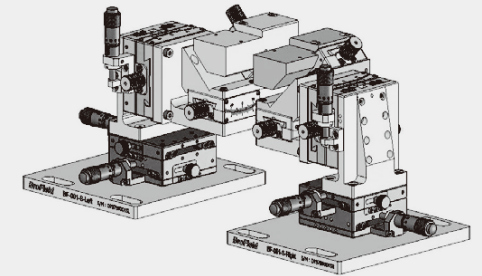
Micro-alignment module for AOI system.



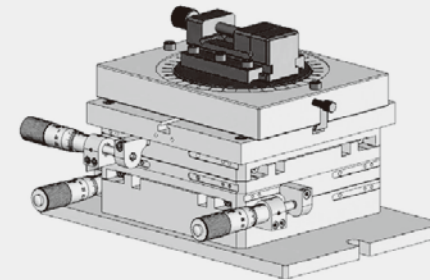
XYR-axis alignment stage module.



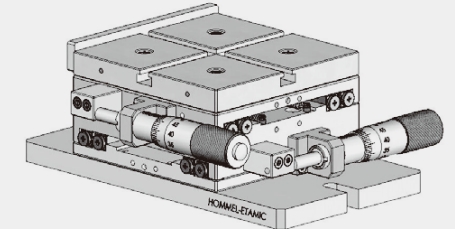
LED wafer characteristic inspection stage module.



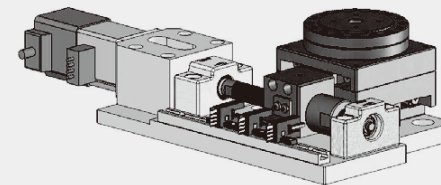
Profile measuring module.



Stage module for surface roughness measuring.



Single axis movement module of large-scale alignment stage.



Lathing stage module equipped with mini-size motors

